

SIHI® Dry PD H Series Single-stage, dry-running vacuum pumps for process applications

Models H250, H400, H630, H750 and H1000



Deep vacuum in a clean, dry-running design

SIHI® Dry PD H Series vacuum pumps were specifically developed for use in chemical, pharmaceutical and other process applications requiring deep vacuum. Unlike conventional twin-screw vacuum pumps, SIHI Dry PD H Series pumps do not require fluids for lubricating. Their dry-running design eliminates fluid acquisition and disposal costs while allowing uncontaminated solvent and process vapors to be recovered downstream. Moreover, the SIHI Dry PD H Series was designed to perform maximum pumping speed at low inlet pressure offering the highest efficiency and lowest power consumption.

Benefits

- High reliability, even under harsh process conditions, due to particle and liquid carryover possibility and safe handling of condensable, corrosive or toxic media
- **High availability** due to integrated condition monitoring with pre-failure detection and data logging
- **Minimal downtime** due to self-draining, top-down flow and simple on-site serviceability by own staff
- Low total cost of ownership due to elimination of lubrication and mechanical seals, low-maintenance costs and energy-efficient design

Applications

SIHI Dry PD H Series dry-running vacuum pumps are engineered to develop deep vacuum under demanding process conditions, including those in classified areas.

Principle industries

- Chemical
- Fine chemical
- Pharmaceutical

Key vacuum applications

- Distillation
- Drying
- Batch reactors



Figure 1: SIHI Dry H400 pump

General technical data

Parameter	Units	H250	H400	H630	H750	H1000
Max. suction capacity	m³/h (cfm)	270 (159)	400 (235)	600 (353)	750 (441)	950 (559)
Final pressure	mbar a (mtorr a)	< 0.1 (75)	< 0.02 (15)	< 0.02 (15)	0.1 (75)	< 0.02 (15)
	Cat 2	€x 2 G 0	C T3 / T4 Gb		😥 II 2 G IIC T3 GI)
ATEX	Cat 1	€ II 1/2 G IIC/ IIC T4 Ga/Gb				
		😥 II 1/2 G IIB3/IIC T4 Ga/Gb				
Absorbed power at final pressure	kW (hp)	5 (6.7)	7 (9.4)	10 (13.4)	14 (18.8)	18 (24.1)
Max. backpressure	mbar g (torr g)			100 (75)		
Gas inlet temperature	°C (°F)	` ′	/ 0 to + 60 (1G) / 32 to 140 (1G))	0 to + 100 (32 to 212)		
Gas outlet temperature	°C (°F)	· '	/ ≤ 160 (T3) / ≤ 320 (T3))	≤ 160 (T3) (≤ 320 (T3))		3))
Sound pressure level ¹	dB (A)	< !	< 63 < 64 < 73		73	
Pump weight	Kg (lb)	6	approx. 600 (1,323	3)	approx. 10	000 (2,205)

Electrical data

Parameter	Units	H250	H400	H630	H750	H1000
Power connection	-	L1, L2, L3, PE (without N)				
Voltage	VAC	400 to 500 ± 10%				
Frequency	Hz	47 to 63				
Protection	-	IP54				
Max. power consumption	kW (hp)	12 (*	16.1)	19.5 (26.1)	26 (34.9)	30 (40.2)
Pre-fuse (three-pole)	А	25 50 63			3	

Purge gas

Parameter	Units	H250	H400	H630	H750	H1000
Medium	-	N_2				
Gas quality	-	min class 2.4.1 (according ISO 8573-1:2010)				
Purge gas consumption (in operation)	NI/min (SCFM)	20 (0.71)				
Pressure	bar g (psig)	3 to 8 (43.5 to 116)				

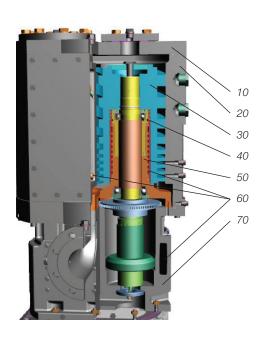
Cooling water

Parameter	Units	H250	H400	H630	H750	H1000
Medium	-	water, conductivity > 50 μS (demineralized water on request)			st)	
Medium temperature	°C (°F)	+10 to +20 (T4) / (50 to 68 (T4) /	, ,	+10 to +40 (50 to 40)		0 +30 0 104)
Max. admissible static medium pressure	barg (psig)	6 (87)		6 (87)	
Min. flow rate	I/min (gpm)		> 8 (2.1)		60 (15.9)

Material design

Wetted parts, process and coolant media sides

Parameter	Item number	H250	H400	H630	H750	H1000
Casing cover	10			1.0553		
Casing	20		EN-G	3JS-400-	18-LT	
Twin screws	30	1.4122				
Labyrinth seal	40	EN-GJL-250				
Bearing cartridge	50	1.4122				
Coolant loop	60	Brass, EPDM / Stainless steel, Copper / GJS				
Motor casing	70	EN-GJS-400-18-LT				
Inlet strainer (not shown)			Stainless steel / PTFE			



Features and benefits

Built for harsh processes

Tolerates particle and liquid carryover without any suction side filter

- Top-down flow avoids particle deposits inside of the pump
- No wear caused by particle carryover due to contactfree principle
- Optional integrated liquid cleaning by flushing module
- Particle carryover and pump drying by optional integrated gas flushing module

Handling of condensable and corrosive media

- Prevention of condensation inside of the pump by optional integrated gas dilution module
- Optional integrated liquid cleaning by flushing module
- Reduction of condensation by temperaturecontrolled operation

Safe handling of toxic media

- Hermetical, tight execution
- Pump internal secondary cooling loop, decoupled from customer cooling water



Improved product quality

High pumping performance

- Remarkably high pump speed at low pressure allows higher flow rate of process gases
- Lower final pressure

Zero process contamination

- Truly dry and contact-free principle, free of any service liquids
- Absolutely free of gear oil due to electronically synchronized shafts

Engineered for easy system integration

Certified explosion protection

- ATEX-certified, even without flame arrester in Category 2 systems
- No source of ignition due to consequential contactfree operation

Customized vacuum system solutions

• Pre-engineered modules match all individual process needs

No pressure control valve necessary

· Adjustable suction capacity due to variable rotational speed

An integrated solution

- Pre-engineered modules are completely mounted and tested
- Small-footprint design saves useful space

No PLC Control necessary with optional HMI

- Self-controlled, pre-engineered modules
- Local control via human machine interface (HMI) panel
- Data access via Ethernet

Easy communication

- Availability of bus standards as well as I/O interface
- Optional equipped with HMI

Fast installation and startup

Self-controlled vacuum system

• Completely assembled, wired, tested and self-controlled vacuum system allows easiest commissioning

Lower maintenance costs and downtime

No oil checks, exchanges and disposals required

- Free of oil as service liquid
- No gear oil

No wearing

- Consequent contact-free principle
- Long-life bearings
- Contact-free sealings

Continuous condition analysis

- Data logging
- Online monitoring of pump status
- Simple failure codes

Easy to clean and service

Only cleaning on demand

- Condition monitoring by independent data record of both shafts
- Pre-failure detection

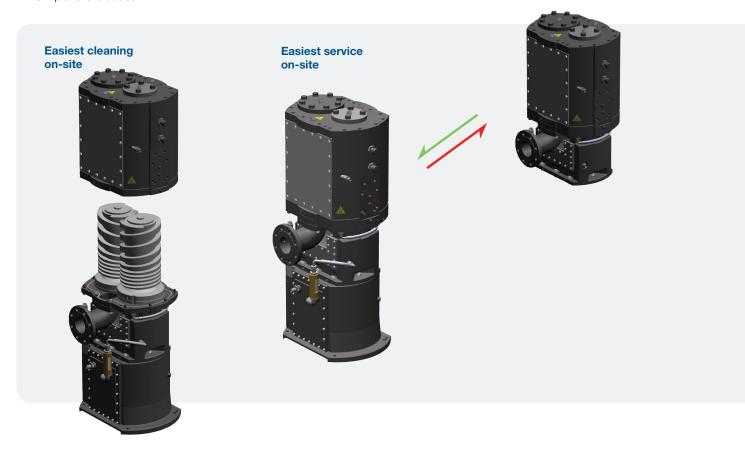
Designed for in situ cleaning and on-site service

- Easy dismantling of the pump casing without bearing removal
- No high-tech workshop required
- Can be done on-site by own staff
- Independency on third party service

Lower operating costs

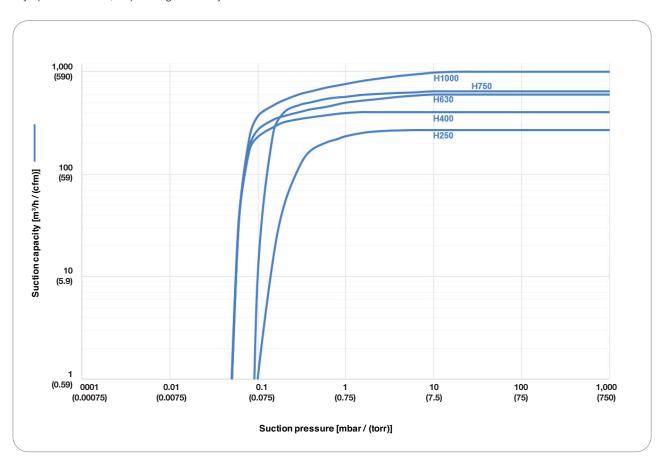
Low power consumption

- High-tech screws' design optimized for highest efficiency
- Frequency control allows to improve energy-efficient operation by operator



Suction capacity curves

Operating points below the characteristic curve are achievable by speed variation, depending on the system execution.



The operating data is valid under following conditions:

- Process media: Dry air 20°C (68°F)
- Cooling media inlet: Water 25°C (77°F)
- Discharge pressure: 1,013 mbar (760 torr) atmospheric pressure
- The suction volume is related to the pressure at the suction nozzle.

Tolerance on operating data is \pm 10%.

Pre-engineered systems

SIHI Dry PD H Series pumps are available in cost-effective standard packages to ensure peak performance and minimize engineering delays. These fully tested and documented pre-engineered systems enable you to deploy a completely new system quickly or upgrade an existing one.

	Modules	Pre-engineered systems			
	Modules	Standard	Configured	Premium	
Vacuum pump	SIHI Dry H250, H400 and H630	X	X	X	
Control	Control FX	X	X		
Control	Control Profibus DP with HMI			X	
Supply unit	Supply unit			X	
Supply unit	Protective motor switch			X	
Purge gas	Purge gas system	X	X	X	
Base frame	Base frame		X	X	
base traffie	Rack			X	
Cooling	Direct cooling without flanges	X			
Cooling	Secondary cooling circuit		X	X	
Shut-off valve suction	Butterfly valve		×	×	
Flushing	Threaded		X	X	
Gas dilution	Standard		X	X	
Shut-off valve discharge	Butterfly valve		X	X	
	Evaluated Pt100 sensor in cooling jacket	X	X	X	
	Evaluated Pt100 sensor on discharge side	X	X	X	
Sensors	Evaluated Pt100 sensor on suction side			X	
	Evaluated pressure-side pressure transmitter	X	X	X	
	Evaluated suction-side pressure transmitter		X (not evaluated)	X	
		- L			







Pre-engineered systems — Standard

This system configuration provides basic equipment for the operation of the vacuum pump. The scope of supply includes the following components:

Modules		Description
Vacuum pump	SIHI Dry H250, H400 and H630	PumpSuction sieveIntegrated motorsIntegrated drive control
Control	Control FX	SIHI Control FX fixed-sequence control with sensor evaluation Integrated communication interface
Purge gas	Purge gas system	Purge gas control unit Ex-p
Cooling	Direct cooling without flanges	Customer's coolant system is directly connected to the pump. A strainer is installed in order to protect the pump.
Sensors	Thermometer and pressure transmitter	Evaluated Pt100 sensor in cooling jacket and on discharge side Evaluated pressure-side pressure transmitter

Available communication interfaces:

I/O interface

• Digital I/O

Ex – p Release / Start / Stop / Reset / Operation / Failure / Warning

• Analog I/O

Set value speed / Vital status / Current speed value

Bus - Communication

- CANopen Slave ISO11898
- Pump control (see I/O)
- Display of operation mode

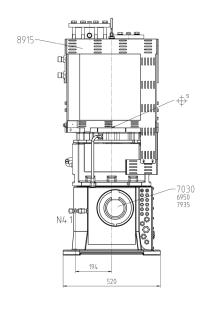
Bluetooth® - Communication

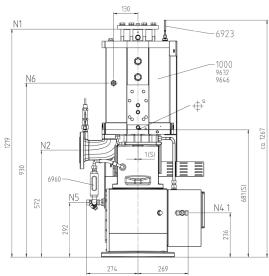
 On-site operation via tablet-PC, SIHI BT remote app via Bluetooth communication and vacuum pump integrated SIHI Control FX sequence control

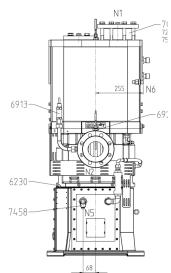


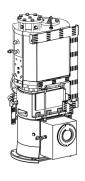
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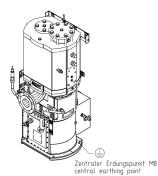
Dimensions for H400 (mm)

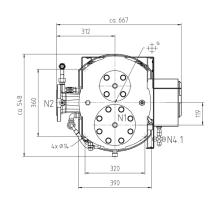




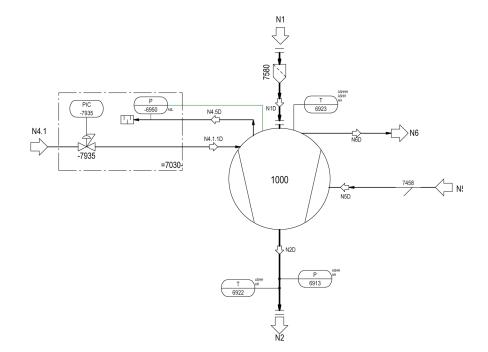








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Pre-engineered systems—Configured

This system configuration provides an extended basic equipment for the operation of the vacuum pump. The scope of supply includes the following components:

Modules		Description
Vacuum pump	SIHI Dry H250, H400 and H630	PumpSuction sieveIntegrated motorsIntegrated drive control
Control	Control FX	 SIHI Control FX fixed-sequence control with sensor evaluation and control sequences such as Start, Stop, Warm up, Standby, Vacuum, Cleaning and Failure Integrated communication interface
Purge gas	Purge gas system	Purge gas control unit Ex-p
Base frame	Base frame	Base frame with machine feet
Cooling	Secondary cooling	Secondary cooling circuit with cooling pump
Shut-off valve suction	Butterfly valve	Controlled, suction shut-off valve
Flushing	Threaded	 Controlled N₂ flush and cleaning valve
Gas dilution	Standard	Controlled gas dilution module
Shut-off valve discharge	Butterfly valve	Controlled discharge shut-off valve
Sensors	Thermometer and pressure transmitter	 Evaluated Pt100 sensor in cooling jacket Evaluated Pt100 sensor in discharge side Evaluated pressure-side pressure transmitter Suction-side pressure transmitter

Available communication interfaces:

I/O interface

• Digital I/O

Ex – p Release / Start / Stop / Reset / Operation / Failure / Warning

• Analog I/O

Set value speed / Vital status /

Current speed value

Bus - Communication

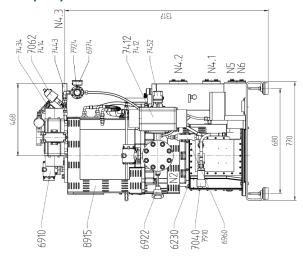
- CANopen Slave ISO11898
- Pump control (see I/O)
- Display of operation mode

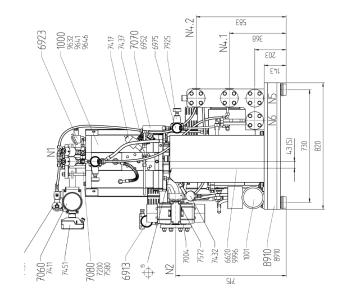
Bluetooth — Communication

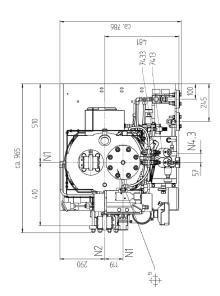
 On-site operation via tablet-PC, SIHI BT remote app via Bluetooth communication and vacuum pump integrated SIHI Control FX sequence control

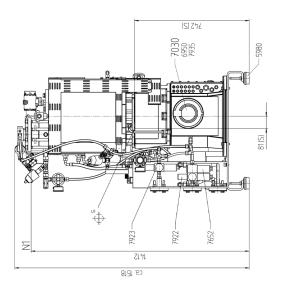


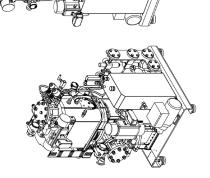
Dimensions for H400 (mm)



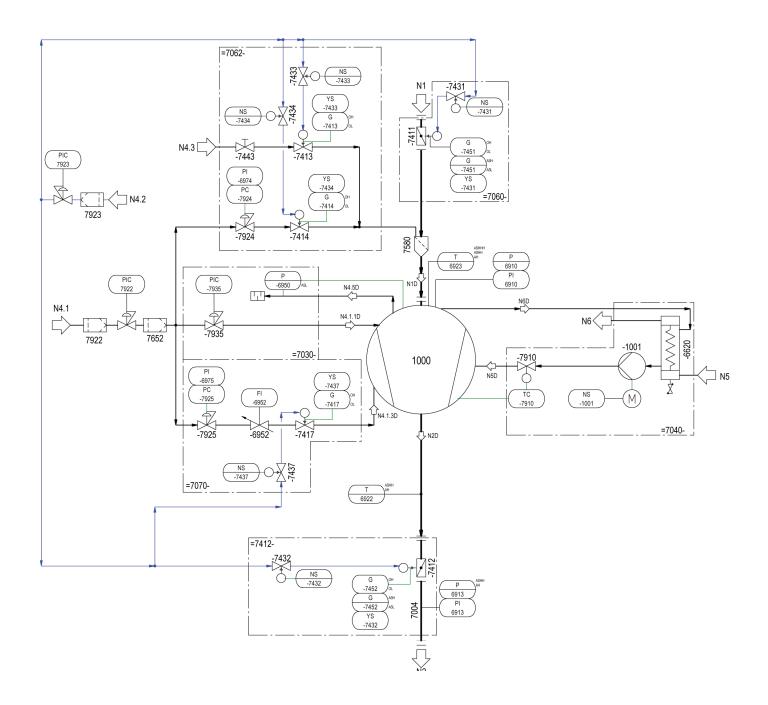








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Pre-engineered systems—Premium

In addition to the extended basic equipment, this system configuration includes a supply and control unit with HMI display. This allows convenient on-site operation and visualization of the vacuum pump status. The scope of supply includes the following components:

Modules		Description
Vacuum pump	SIHI Dry H250, H400 and H630	 Pump Integrated motors Suction sieve Integrated drive control
Control	Control Profibus DP with HMI	 Standard control with sequence control and sensor evaluation Programmable sequence control with different operation modes such as Start, Stop, Warm up, Standby, Vacuum, Injection Cleaning, Post Run and Failure Variable control parameters such as: Warm up Temperature / Flush Drying Time / Standby Speed Integrated communication interface
Supply unit / operation	Supply unit Protective motor switch	 Plug-in solution with integrated transformer for 24 VDC control voltage generation to supply: Display control unit SIHI Dry power supply switch Cooling pump motor overload switch
Purge gas	Purge gas system	Purge gas control unit Ex-p
Base frame	Base frame and rack	Rack for supply unit, control unit and motor overload switchBase frame with machine feet
Cooling	Secondary cooling circuit	Secondary cooling circuit with cooling pump
Shut-off valve suction	Butterfly valve	Controlled suction shut-off valve
Flushing	Threaded	Controlled N ₂ flush and cleaning valve
Gas dilution	Standard	Controlled gas dilution module
Shut-off valve discharge	Butterfly valve	Controlled discharge shut-off valve
Sensors	Thermometer and pressure transmitter	 Evaluated Pt100 sensor in cooling jacket, suction and discharge side Evaluated pressure-side pressure transmitter Evaluated suction-side pressure transmitter

Pump system control with HMI display (control unit) and sequence control

- Programmed standard control with control sequences such as Start, Stop, Warm up, Standby, Vacuum, Injection Cleaning, Post Run and Failure
- Dirt detection
- Identification bearing lifetime end
- Detailed display of operation mode
- Programmable performance field

Communication interfaces

Bus - Communication

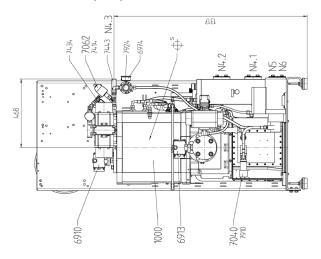
- Profibus DP (IEC 61158)
- Pump control (see control)
- Display of operation mode

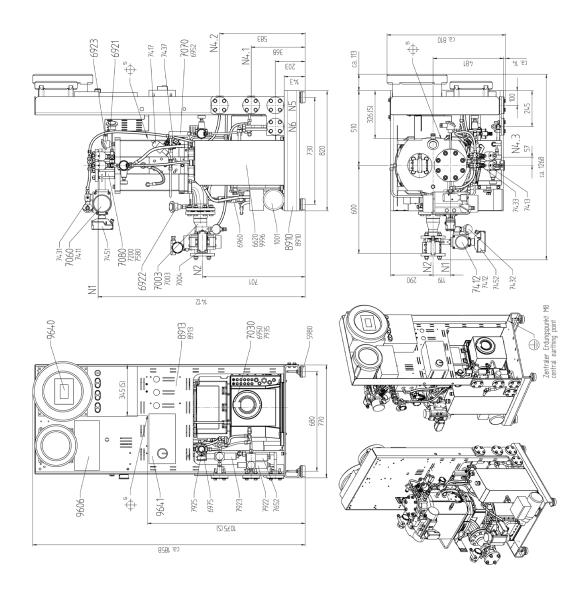
On-site display

- Visualisation
- On-site operation
- Data logger

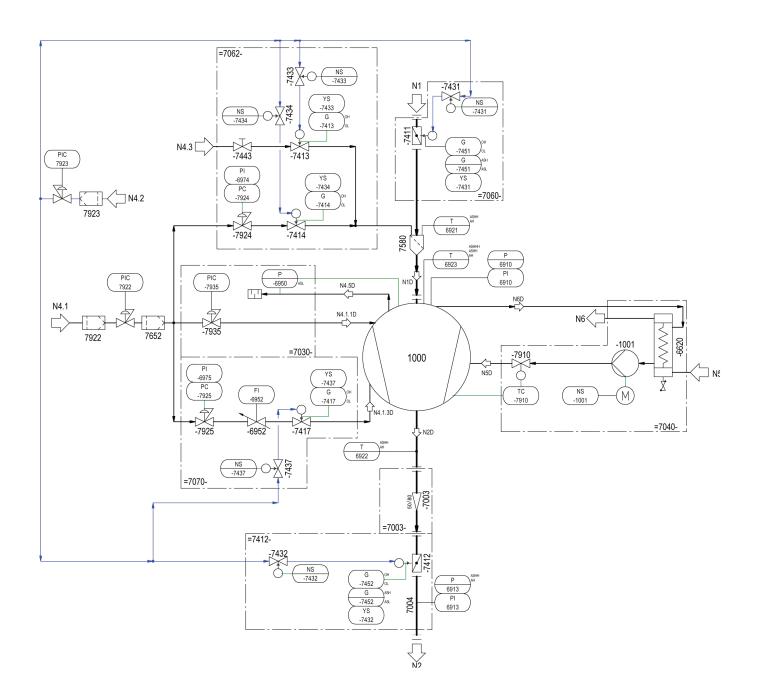


Dimensions for H400 (mm)





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Standard modules for specific applications

SIHI Dry H Series vacuum pump systems can be configured from pre-engineered modules to meet exact system requirements.

Numerous modules are available.

Vacuum pump	Execution	Features
SIHI Dry H250, H400, H630, H750 and H1000	PumpSuction strainerIntegrated motorsIntegrated drive control	Two screw-shaped displacing bodies rotating in opposite directions without contact

Control	Execution	Features
Basic	Integrated in pump Control of internal temperature Control of torque Electronical overload protection On-site operation via tablet-PC, SIHI BT remote app via Bluetooth communication	Operations: Start, stop Status messages: Failure signal No valve control No sensor evaluation
Dynamic Characteristic:	Like control variant Basic , additionally: Variable speed via integrated frequency converter	Operations: Start, stop, variable speed Status messages: Failure signal No valve control No sensor evaluation
SIHI Control Fx Characteristic: Sequence chart: Ready to start Startbeet Start Beardy to start Start Beardy to start Startbeet Nachspülen Stop Stop Warm Up Warm Fahren Vacuum request Vacuum Anderderung Vacuum peration Vakuum Betrieb	Like control variant Dynamic , additionally: On-site operation via tablet-PC, SIHI BT remote app via Bluetooth communication and vacuum pump integrated SIHI Control FX sequence control Fixed parameter Data logger Detailed status messages Control of internal temperature Control of torques Electronical overload protection Programmed valve control (for all standard valves) Input for digital signals Digital status messages	Communication: Operations: Start, stop, vacuum, cleaning, post run Speed set value: Digital Display of operation, Mo Failure, Operation Warning, Failure, Failure messages, etc. Valve control: Valve, suction side Valve, discharge side Gas dilution Cleaning (liquid flushing) Gas flushing (N ₂ flushing) Sensor evaluations: Limit switch, suction side valve Imit switch, discharge side valve Pressure transmitter Temperature sensor
		Digital inputs: Start, Stop, Vacuum, Cleaning, T _{min} (Warm up), X _{max} (Maximum value evaluation for temperatur and pressure) Digital status messages: No Failure, Operation, Warning, Failure, Vacuum, Cleaning

Control	Execution	Features			
Control Profibus DP	Control and supply unit mounted directly on the vacuum system	Housing:	Coated aluminium/ polyester resin		
	On-site operation via HMI	Communication:	via Profibus DP (IEC 61158)		
	Variable parameters for process optimizing as: Pre-run, flushing, post-run timers	Operations:	Start, stop, vacuum, cleaning, post run		
	Data logger	Speed set values:	Digital, via Profibus		
S-AMANAN-CI	Ethernet connection for additional monitoring respectively, connection of modem for remote maintenance	Display of operation, modes such as:	No Failure, Operation Warning, Failure,		
Characteristic:	Detailed status messages		Failure messages, etc.		
s	Control of internal temperature	Valve control: Valve, suction side			
	Control of torques	Valve, discharge side			
	Electronical overload protection	Gas dilutionCleaning (liquid flush)	ina)		
Sequence chart:			ing (N ₂ flushing)		
Ready to start Gas flushing		Sensor evaluations:			
Startbereit Nachspülen Stop	Programmed valve control (for standard valves)	Limit switch, suctionLimit switch, dischar			
Rotor diagnosis Rotor diagnose	Input for digital signals	Pressure transmitters	~		
Warm Up Stand By Reinigen	Digital status messages	Temperature sensors	8		
Warm Fahren Vacuum request Vakuum Anforderung	Cooling pump control (including post-run)	Digital inputs:	Start, Stop, Vacuum, Cleaning, Tmin (Warm up),		
I Vakuum Antorderung Vacuum operation Vakuum Betrieb	Cooling pump status message via bus available		X _{max} (Maximum value evaluation for temperature and pressure)		
		Digital status messages:	No Failure, Operation, Warning, Failure, Vacuum, Cleaning		

Supply unit / operation	Execution	Features	
Supply unit	Plug-in solution with integrated transformer for 24 VDC control voltage generation for display control unit SIHI Dry – Ex-p circuit switch (separation of SIHI Dry supply voltage)	Housing:	Coated aluminium/ polyester resin
P	and communication line with contactors) Wired and mounted on common rack Main switch (lockable) Installation of SIHI Dry and supply unit in Ex-zone 1	Electrical connectors Frequency: Voltage:	50 Hz 3 x 400 – 500 VAC, PE
Protective motor switch	Coolant pump is controlled via control unit (9X) started and stopped Motor overload switch (externally accessible) Wired and mounted on common rack	Housing: Electrical connectors Frequency: Voltage:	Coated aluminium/ polyester resin stion: 50 Hz 3 x 400 – 500 VAC, PE

Purge gas	Execution	Features	
Purge gas system	Motor and electronics of SIHI Dry are kept under overpressure with shielding gas. It permits pump installation within a hazardous area.	Housing:	Stainless steel
	The purge gas system controls the necessary operating conditions.	Connection:	DN12 pipe fitting

Base frame	Execution	Features
Base frame	Pump (if applicable with secondary cooling curcuit and/or emission condensoer) are mounted together on a base frame with four machine feet.	
Rack	Additionally to base frame: Rack assembly for supply unit and control unit	

Cooling	Execution	Features
Direct cooling	The connection to customer's coolant system is realized with flanges (requires base frame).	Material execution: service side pipe/fittings: 1.4571/NBR Cooling water connections: 2 x DN25 PN40
Direct cooling with thermostatic valve	Additionally to direct cooling: A temperature controller is installed to adapt the current demand of customer's coolant.	Like direct cooling, additionally: Material execution: service side thermostatic valve: Brass

Cooling	Execution	Features	
Secondary cooling circuit	Closed cooling loop for SIHI Dry Internal secondary cooling loop is decoupled from customer side cooling water Protection against contamination and calcification Homogeneous tempered SIHI Dry via temperature controller	Material execution Cooling loop: Pipe / fittings: Cooling water connections: Electrical connection	1.4571 1.4571 2x DN25 PN40
60		Frequency: Voltage: or	50 Hz 3 x 400 VAC, PE 3 x 500 VAC, PE
Secondary cooling with	Additionally to secondary cooling circuit:	Like secondary coo	oling, additionally:
thermostatic valve	A temperature controller is installed to adapt the current demand	Material execution	service side thermostatic
7	of customer's coolant.	Valve:	1.4581
		Voltage: or	3 x 400 VAC, PE 3 x 500 VAC, PE

Shut-off valve, suction side	Execution	Features
Butterfly valve	Isolation of the vacuum pump from the reactor: Entry of medium into the working chamber after process is prevented Backflow through the pump and resulting ventilation of the reactor are avoided.	Scope of supply: Valve, PFA/PTFE conductive lined Drive, designed for control pressure of 3 to 6 barg (43 to 87 psig), closed by spring energy Solenoid valve Limit switch

Gas and liquid flushing	Execution	Features
Flanged	The gas flushing using inert gas allows drying or also the discharge of residual gases from the work chamber. In addition, a liquid flush can remove particles or deposits. The flushing can be activated by a cleaning request, post-run or injection flushing.	Scope of supply: • 2/2-ways-valve, DN25, stainless steel / PTFE with drive, designed for control pressure of 3 to 6 barg (43 to 87 psig), closed by spring energy • Solenoid valve • Pressure reducer • Needle valve • Stainless steel piping
Threaded	Like above, but threaded connections instead of flange connections.	Scope of supply: • 2/2-ways-valve, G ½ in, stainless steel / PTFE with drive, designed for control pressure of 3 to 6 barg (43 to 87 psig), closed by spring energy • Solenoid valve • Pressure reducer • Needle valve, stainless steel

Connection, suction side	Execution	Features
Adapter	Adapter for installation of sensors and/or flushing valves on suction side for systems with flame arresters.	Material execution: Stainless steel 1.4571

Gas dilution	Execution	Features
For H250 to H630	To minimize deposits and corrosion, dry inert gas (e.g., nitrogen) is injected into the working space of the SIHI Dry pump.	Scope of supply: • 2/2-ways-valve, G ½ in, stainless steel / PTFE with drive, designed for control pressure of 3 to 6 barg (43 to 87 psig), closed by spring energy • Solenoid valve • Flow indicator (430 to 4,300 Nl/h, 15.2 to 152 SCFM) with needle valve • Pressure reducer
For H750 and H1000	To minimize deposits and corrosion, cooled exhaust gas from the emission condenser is returned to the SIHI Dry working chamber	Material execution: Stainless steel 1.4571

Shut-off valve, cooling discharge side	Execution	Features
Butterfly valve	Isolation of the vacuum pump from the exhaust line. The pump will be decoupled from the vent system and is protected from condensable media during standstill.	Scope of supply: Valve, PFA/PTFE, conductive lined Drive designed for control pressure of 3 to 6 barg (43 to 87 psig), closed by spring energy Solenoid valve Limit switch Stainless steel measuring branch
Discharge condenser for H250 and H400	Discharge condenser for condensation of vapors.	Type: Plate and shell – condenser Exchange area 2.1 m² Material execution (product / service side): Stainless steel / stainless steel or Stainless steel / steel Connections: Process side: DN50/PN16 Service side: DN25/PN16
Emission condenser for H630, H750 and H1000	To minimize deposits and corrosion, cooled exhaust gas from the emission condenser is returned to the SIHI Dry working chamber.	Type: • Tube & shell – Condenser • Exchange area 1,7 m² Material execution (product / service side): • Stainless steel / Stainless steel Material executionConnections: • Process side: DN50/PN16 • Service side: DN25/PN16 • Gas feedback: DN80/PN16 • Ventilation: G 1/8" • Drain service port: G 1/2" • Measuring port: G 1/2"
Emission condenser with shut-off valve for H630, H750 and H1000	Addionally to Emission condenser for H750 and H1000: Shut-off valve Like mission condenser for H750 and H1000, additionally:	Scope of supply: Valve, PFA/PTFE- conductive lined Drive, designed for control pressure of 36 bar g, closed by spring energy Solenoid valve (Ex-e) Limit switch (Ex-d)

Connection, discharge side	Execution	Features
Transition pipe	For connection of components on the discharge side, i.e., discharge condenser.	Material execution: Stainless steel

Sensors	Execution
Resistance thermometer	Resistance thermometer (Pt100) for measuring temperature on suction side and/or
	Resistance thermometer (Pt100) for measuring coolant temperature and/or
	Resistance thermometer (Pt100) for measuring temperature on discharge side
Pressure transmitter	Pressure transmitter for measuring of suction pressure and/or
	Pressure transmitter for measuring dynamic pressure or exhaust pressure

Accessories	Execution	Feature	
Flame arrester	Besides the necessary measurement devices, flame arresters (IIB3 for H250 and H400 or IIC for H250) are equipped to fulfil the requirements of a cat 1 system.	Material execution:	Flame arrester IIB3: stainless steel Flame arrester IIC: stainless steel



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